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Atty. Docket No. OPP031047US

MAR 15 2006

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF:

:

Jae-Won HAN

: GROUP ART UNIT: 2812

APPLICATION NO: 10/751,172

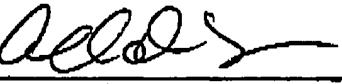
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FILED: DECEMBER 30, 2003

: EXAMINER: NGUYEN, Ha T.

FOR: METHOD FOR MANUFACTURING
SILICIDE AND SEMICONDUCTOR
WITH THE SILICIDE

I hereby certify that this document is being facsimile transmitted to the USPTO or deposited with the United States Postal Service as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on March 15, 2006.

By: 
Andrew Fortney

AMENDMENT AND REQUEST FOR RECONSIDERATION UNDER 35 U.S.C. 132
AND 37 C.F.R. 1.111

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SIR:

Responsive to the Office Action dated December 15, 2005, Applicant respectfully requests reconsideration of the above-identified application in view of the following amendments and remarks.